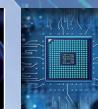
Leybold

©

Vacuum for Research & Development







Best conditions for unusual solutions

Extensive research & development often precedes great technological breakthroughs and advancements.

Our vacuum engineering specialists are able to customize solutions for you by taking advantage of our vacuum expertise and experience. We want to partner with you from the very beginning of your research and help you to meet your goals and ultimately achieve success.

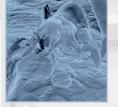












Take a look into the future



Observatories high atop Mauna Kea volcano, Hawaii, at sunset.

Vacuum technology not only enables us to gaze into the future but also to peer into the distant past. Giant telescopes like the ones used at Mauna Kea Observatory in Hawaii, the Instituto de Astrofisica in the Canary Islands and the European Southern

Observatory in Chile rely on their flawless mirrors whose reflective coatings would not be possible without vacuum technology such as that provided by Leybold.

Material sciences

Material science is an interdisciplinary field which deals with the discovery and design of new materials, involving studies of its synthesis, structure, properties and performance. The research activities cover the whole range of materials including electronics, optical and magnetic materials, polymers, medical implant materials and nanomaterials like e.g. Graphene. Thus it is a main driver for the development in the fields of electronics, pharmaceutics & medicine, energy, nanotechnology and industrial production of materials in general.

Example applications:

- Research for new coating processes
- Material research
- Nano structures
- Layer performance (thin layer technology)

Products

Modular turn-key UHV experimentation systems

UNIVEX high vacuum multi-chamber experimentation systems





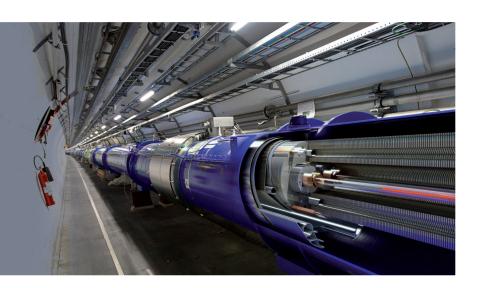
Optical coatings should improve reflection or transmission properties of optical systems such as filters, lenses, eye glasses or mirrors. Typical optical coatings are a composition of various thin film layers for antireflection (e.g. eye glasses), high-reflector (e.g. filters) or transparent conductive coatings. They are produced by state-of-the-art sputtering or evaporation processes.

Products

Turbomolecular pumps TURBOVAC MAG with magnetic suspension TURBOVAC i/iX with hybrid bearing technology Dry fore-vacuum pumps ECODRY plus roots pumps DRYVAC, LEYVAC screw pumps SCROLLVAC SC / plus scroll pumps



Particle accelerators generate high energy particles (electrons, protons, ions) for fundamental nuclear research.



High Energy Physics

In many research centers storage rings are joined to accumulate a high beam current and accelerate to higher energies. Highest energies are achieved today at the LHC ring at CERN (Geneva).

Many storage rings use the synchrotron light generated in electron storage rings as a brilliant source of radiation e.g. for material science. While linear accelerators require at least high vacuum pressures, the storage rings need ultra-high vacuum, in very large machines 10⁻¹¹ mbar or below!

Products

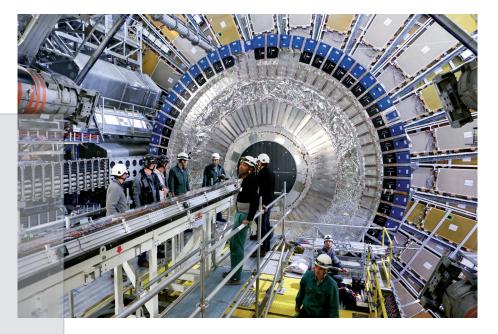
Oil-sealed and dry compressing vacuum pumps, systems and turn-key solutions

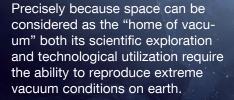
Turbomolecular pumps TURBOVAC with mechanically suspended and TURBOVAC i/iX with hybrid bearing technology TURBOLAB high vacuum pump systems

COOLVAC refrigerator cryo pumps **COOLPOWER** cold heads for cooling cryo pumps/cryostats

TiTan[™] ion pumps SCROLLVAC SC /plus scroll pumps ECODRY plus multi-stage roots pumps PHOENIX helium leak detectors and systems

Leybold offers excellent knowledge on the material and equipment behavior in hard radiation and within strong magnetic fields. This is mandatory to generate and maintain the insulation vacuum of very large superconducting magnets and to safeguard the required leak tightness.







Space travel, scientific and commercial satellites, extraterrestrial research such as ESA's Rosetta mission or NASA's mars rover Opportunity can only be successful if all involved materials, components and devices are successfully tested under high-vacuum and ultrahigh-vacuum conditions. Space simulation chambers vary in size from few liters for testing of e.g. small PCB boards up to several thousand cubic meters to prove space compatibility of complete spacecrafts. However, also terrestrial space observation often requires vacuum, e.g. for mirror coating in telescopes.

Products

COOLVAC cryo pumps COOLPOWER cold heads

Turn-key vacuum system solutions, tailor-made to individual requirements with integrated forevacuum and high vacuum pumps

DIP oil diffusion pumps

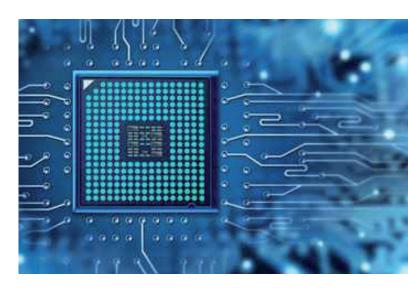
PHOENIX helium leak detectors and systems

UNIVEX S space simulation system

Comprehensive consulting service, customer specific application support and trainings

Our modern life is pervaded by electronics – visibly and invisibly. Most of today's highly integrated circuits in computers, smart phones, cars, home automation, medical technology etc. are based on semiconductor technologies. Also the generation of renewable energy by solar panels is only possible by suitable semiconductor processes. Most of these harsh processes rely on the presence of reliable and stable vacuum conditions.

Electronics



Products

SCREWLINE and DRYVAC dry compressing screw vacuum pumps

TURBOVAC MAG turbomolecular pumps with magnetic suspension

Analytics

Products

TURBOVAC turbomolecular pumps with mechanical or hybrid suspension

TURBOLAB

high vacuum pump systems **DIVAC** diaphragm pumps

SCROLLVAC SC / plus

scroll pumps **ECODRY plus** multi-stage roots pumps **SOGEVAC** rotary vane pumps, single-stage Vacuum measurement and control equipment Analytical instruments today are a strong driver of product improvements. Be it mass spectrometers for water and food quality control or drug development, X-ray analysis in material quality investigation, electron microscopes in biological and semiconductor research or surface analysis in basic material science – most analytical instruments operate in high or even ultra-high vacuum regime.

Most of these instruments use turbomolecular pumps with mechanical or magnetic bearings. Quality of vacuum composition and high uptime of the vacuum system are mandatory requirements for the operation of analytic instruments.

SOGEVAC / TRIVAC Rotary vane vacuum pumps

Effective investment, long service life. No oil loss, low power consumption.

SOGEVAC

- Pumping speed 10 to 1,200 m³/h - Ultimate pressure $\leq 5 \cdot 10^{-2}$ mbar TRIVAC
- Pumping speed 2,5 to 65 m³/h
- Ultimate pressure $\leq 5 \cdot 10^{-4}$ mbar

DIVAC

Diaphragm pumps Corrosion resistant vacuum pump for laboratories. Backing pumps for turbo-

molecular pumps. Environment-friendly, low operating costs.

SCROLLVAC SC / plus

Oil-free scroll pumps

Dry, universal solution for quiet,

low vibration operation.

Low operating cost and long maintenance intervals.

- Pumping speed 0.8 to 4.8 m³/h and 0.6 to 2.2 m³/h for corrosive media
 Ultimate pressure ≤ 1 mbar
- Dry operation, oil-free
- Media contacting parts made of PTFE and PVDF
- Pumping speed 5 to 60 m3/h
- Ultimate pressure $\leq 1 \cdot 10^{-2}$ mbar
- Robust, low-maintenance design
- High pumping speed even at 1000 mbar

ECODRY plus

Dry compressing multi-stage roots pumps

- Compact vacuum pumps with low noise emission for clean applications.
- Pumping speed 40 to 65 m³/h
- Lowest noise level in class
- Air-cooled pump
- Oil and particle-free operation

LEYVAC / SCREWLINE / DRYVAC

Dry compressing screw pumps and systems

Rugged vacuum pumps for rough applications and high process throughputs. Smart monitoring and control system for process industry applications. Direct connection of RUVAC Roots pumps via adapter.

- LEYVAC
- Pumping speed 80 to 300 m³/h SCREWLINE
- Pumping speed 250 and 630 m³/h
- Ultimate pressure $\leq 1 \cdot 10^{-2}$ mbar
- DRYVAC
- Pumping speed 450 to 5,000 m³/h

Vacuum Systems

Forevacuum pump systems / Helium pump systems Vacuum solutions and systems of all kinds - Design and manufac

including customer specific application support.

Benefit from our long-term experience.

TURBOLAB

High vacuum pump systems

Plug-and-play high vacuum pump systems based on well-proven components. Different configurations cover individual vacuum demands.

- Design and manufacture of custom vacuum solutions

- Integrated forevacuum and high vacuum pump systems for custom requirements
- Efficient solutions
- Pumping speed 90 450 l/s
- Ultimate vacuum down to 10⁻¹⁰ mbar
- Completely preassembled as a benchtop unit with turbomolecular pump, frequency converter and fore-vacuum pump















TURBOVAC i/iX

Turbomolecular pumps with hybrid bearing technology

Innovative and flexible product range with outstanding performance data and integrated electronics.

TURBO.CONTROL i display unit (rack version or benchtop unit) to control and monitor the pump including connection facility for two pressure gauges available as accessory.

TURBOVAC

Turbomolecular pumps, mechanically suspended

Turbomolecular pumps, magnetically levitated

Reliable and proven product range for demanding applications with separate pump electronics.

TURBOVAC MAGINTEGRA

and UHV vacuum generation.

Most compact product line for clean high

On-board frequency converter and power

Easy and space-saving system integration.

- Pumping speed up to 440 l/s
- Oil free hybrid bearings
- Integrated electronics including a variety of options for communication and control of accessory components
- Versions for high compression and high gas throughputs available

- Pumping speed up to 1,150 l/s

bearings

-

_

_

and shock venting

lengths > 140 m

Two oil-free mechanical ceramic

Electronics separable with cable

High resistance to mechanical shocks

Pumping speed up to 300 - 2,100 l/s









supply.

Refrigerator cryo pumps

Low maintenance requirements.

High water vapor pumping capability, long maintenance intervals, installation in any orientation.

- Pumping speed up to 60,000 l/sec
- Clamp and CF flange versions

Insensitive to shock-venting

Fully automatic regeneration cycle



Cold heads for cooling cryo pumps/cryostats

Gas refrigerating machines for cryogenic temperature generation based on the

Gifford-McMahon principle.

Designed for cooling superconductors.

- Ultimate temperatures:
 - two-stage models down to 8 K, - single-stage models down to 25 K
- High refrigerating capacity from the smallest volume
- No need for liquid helium and liquid nitrogen

TiTan™

lon pumps

A full range of vibration-free and maintenance-free ion pumps, Titan sublimationpumps and NEG getter pumps to achieve best final pressures in the ultra-high

vacuum.

DIGITEL[™] controller models for most diverse applications and configurations.

- Pumping speed 0.2 1,200 l/s
- Ultimate vacuum $< 1 \times 10^{-10}$ mbar
- Various TiTan[™] pump elements for different requirements available
- All TiTan[™] and TSP components are bakeable up to 400 °C
- Wide range of accessories





High compression ratio for all gases Holweck stage incorporated Resistant to particles and deposits Monitoring and self-protection functions

UNIVEX

Experimentation and coating systems

Easy operation and accessibility of vacuum chambers. Manual or automatic process control and documentation.

- Multipurpose systems for testing and the production of functional layers

Customized system solutions in all sizes

Comprehensive consulting service,

customer specific application support

Highly reliable and precise measurement

intuitive menu structure and comfortable

Integrated webserver for remote control

with any internet-enabled mobile device

Enhanced HMI with simple controls,

up to $5 \cdot 10^{-12}$ mbar l/s

multicolored touchscreen

- Modular system configuration, wide range of accessories
- Customized system solutions
- Variable chamber sizes

and training

UNIVEX S

Space simulation systems

Chamber systems for generation of space simulation conditions under vacuum in all sizes and for a wide variety of experiments and tests.

Turn-key system solutions with integrated fore vacuum and high vacuum pumps.

PHOENIX 4

Leak detectors

Designed for the demanding requirements in research and development. Easy to use and well-proven in research centres, production and quality control

programs. Suitable for mobile or stationary vacuum

and sniffer operation

Measuring Instruments

Vacuum pressure devices, measurement gauges, display units

Reliable monitoring and control for all vacuum processes.

- Measurement with active and passive sensors in a pressure range from 2,000
- to 10⁻¹² mbar for every application
 Pressure switches and pressure control instruments





Flange systems

Connection components, feedthroughs and observation windows

Well proven and widely used technology. Almost any connection possible.

- Small flanges in sizes DN 10 to DN 50
- Clamped flanges in sizes DN 63 to DN 630
- CF flanges in sizes DN 16 to DN 250
- UHV valves / linear motion feedthroughs





